

FESTSCHRIFT SYMPOSIUM

THE ECONOMICS OF

CREATIVE DESTRUCTION

IN HONOR OF PHILIPPE AGHION AND PETER HOWITT

JUNE 9 –12
2021

ORGANIZING COMMITTEE

Ufuk AKCIGIT, University of Chicago

John VAN REENEN, MIT & LSE

INVITED SPEAKERS

Daron ACEMOGLU, Ufuk AKCIGIT, Harun ALP, Pol ÀNTRAS, Sina ATEs, Pierre AZOULAY, Abhijit BANERJEE, Salomé BASLANDZE, Roland BENABOU, Timothy BESLEY, Jim BESSEN, Olivier BLANCHARD, Nicholas BLOOM, Richard BLUNDELL, Patrick BOLTON, Matilde BOMBARDINI, Timo BOPPART, Erik BRYNJOLFSSON, Leonardo BURSZTYN, Murat CELIK, Gilbert CETTE, Angus DEATON, Antoine DECHEZLEPRÊTRE, Jan DE LOECKER, Mathias DEWATRIPONT, Esther DUFLO, John FERNALD, Jesús FERNÁNDEZ-VILLAYERDE, Patrick FRANÇOIS, Oded GALOR, Cecilia GARCÍA-PEÑALOSA, Richard GILBERT, Christian GOLLIER, Robert GORDON, Michael GREENSTONE, Jeremy GREENWOOD, Rachel GRIFFITH, Roger GUESNERIE, Bronwyn HALL, John HALTIWANGER, Oliver HART, John HASSLER, Martin HELLWIG, David HÉMOUS, Chang-Tai HSIEH, Giammario IMPULLITTI, Matthew O. JACKSON, Xavier JARAVEL, Chad JONES, Kolev JULIAN,

Şebnem KALEMLI-ÖZCAN, Pete KLENOW, Samuel KORTUM, Francis KRAMARZ, Michael KREMER, Josh LERNER, Ross LEVINE, Huiyu LI, Jacques MAIRESSE, Ralf MARTIN, Eric MASKIN, Kiminori MATSUYAMA, Marc MELITZ, Atif MIAN, Stelios MICHALOPOULOS, Joel MOKYR, Fiona MURRAY, Tom NICHOLAS, Ariel PAKES, Michael PETERS, Edmund PHELPS, Thomas PHILIPPON, Christopher PISSARIDES, Sergio REBELO, Stephen REDDING, Hélène REY, Patrick REY, Dani RODRIK, Alexandra ROULET, Raffaella SADUN, Felipe SAFFIE, Mark SCHANKERMAN, Michael SPENCE, Stefanie STANTCHEVA, Jeremy STEIN, Nicholas STERN, Scott STERN, Joseph STIGLITZ, Kjetil STORESLETTEN, David STRÖMBERG, Chad SYVERSON, Guido TABELLINI, Jean TIROLE, Otto TOIVANEN, Manuel TRAJTENBERG, Francesco TREBBI, Daniel TREFLER, John VAN REENEN, Reinhilde VEUGELERS, Gianluca VIOLANTE, Jörgen WEIBULL, Heidi WILLIAMS, Fabrizio ZILIBOTTI, Luigi ZINGALES

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